

Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/784,994	FUJIBAYASHI, AKIRA
Examiner	Art Unit	
Patrick M. Moore	2188	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
PLUS Search from EIC (50 Max)	11/10/2005	PMM
707/100,200,201; 709/215,217,219,226; 711/162,114,112,147;  Narrowed with Text Search	11/10/2005	PMM
Text Search for Mirrored Pair RO and R/W modes	11/17/2005	PMM

<b>INTERFERENCE SEARCHED</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>